



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

8/26/03
#5/EOT
(2m45)
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In re application of : Confirmation No. 7678
Kazuyuki NITTA et al. : Docket No. 2001_1703A
Serial No. 09/987,718 : Group Art Unit 1756
Filed November 15, 2001 : Examiner K. Sagar

METHOD FOR FORMING A HOLE-
PATTERNED PHOTORESIST LAYER

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of
March 21, 2003.

The fee of \$410.00 is

☒ (X) submitted herewith.

☐ () to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

☐ () Small entity status of this application is established by a Small Entity Status Assertion
which

☐ () is enclosed.

☐ () has been previously submitted.

Respectfully submitted,

Kazuyuki NITTA et al.

08/21/2003 GWORDDF1 00000037 09987718

01 FC:1252

410.00 DP

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August 20, 2003